

UNITED STATES PATENT AND TRADEMARK OFFICE
CERTIFICATE OF CORRECTION

PATENT NO. : 6,768,110 B2
DATED : July 27, 2004
INVENTOR(S) : Alani

Page 1 of 1

It is certified that error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

Column 13.

Line 58, "comprising providing a specimen having length and thick-" should read
-- comprising: providing a specimen having length and thick- --;

Column 14.

Line 7, "sion of said specimen, evacuating a chamber, position said" should read
-- sion of said specimen, evacuating a chamber, positioning said --;

Line 9, "specimen to provided an electron transparent surface of said" should read
-- specimen to provide an electron transparent surface of said --;

Line 28, "the progress of milling an said milling takes place." should read -- the
progress of milling as said milling takes place. --;

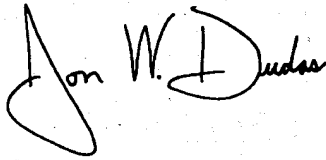
Column 15.

Line 11, "ion beam masking member much that there is no relative" should read -- ion
beam masking member such that there is no relative --; and

Line 20, "group consisting of circular square, rectangular, and ellip-" should read
-- group consisting of circular, square, rectangular, and ellip- --.

Signed and Sealed this

Thirteenth Day of December, 2005

A handwritten signature in black ink, reading "Jon W. Dudas", is enclosed within a dashed rectangular box. The signature is stylized, with the first name "Jon" and last name "Dudas" clearly legible, and "W." in the middle.

JON W. DUDAS

Director of the United States Patent and Trademark Office